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AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 1725  
PATENT APPLICATION

14/1  
5/19/03  
NE

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q63075

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 1725

Confirmation No.: 3832

Examiner: Maria Alexandra ELVE

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN  
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 13, 2003, along with a Petition for Extension of Time and appropriate fee, please amend the above-identified application as follows on the accompanying pages and as allowed by the new format specified in the Pre-OG Notice of January 31, 2003, entitled, *Amendments in a Revised Format Now Permitted*, wherein the requirements of 37 C.F.R. § 1.121 (a - d) have been waived.